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10/815,813

April 2, 2004

Koichiro TANAKA et al.

TRANSMITTAL FORM

(to be used for all correspondence after initial filing)

Group Art Unit

Examiner Name

A. Chambliss

Otal Number of Pages in This Submission

Attorney Docket Number 0756-7283

Total Number of Pages in This Submission		Attorney Docket Number		r 0756-7283	
. ENCLOSURES (check all that apply)					
Fee Transmittal Form Fee Attached Amendment / Reply After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request Information Disclosure Statement Certified Copy of Priority Document(s) Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53				After Allowance Communication to Group Appeal Communication to Board of Appeals and Interferences Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Other Enclosures 1. 2. 3. 4. 5. 6.	
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT					
Firm or Individual name Signature	Eric J. Robinson, Reg. No. 38,285 Robinson Intellectual Property Law Office, P.C. PMB 955 21010 Southbank Street Potomac Falls, VA 20165				
Date	February 2, 2007				
CERTIFICATE OF MAILING					
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.					
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Signature		1.1. m. Atanina		Date	February 2, 2007

Application Number

First Named Inventor

Filing Date

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Attorney Docket No. 0756-7283



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Group Art Unit: 2814 Koichiro TANAKA et al. Examiner: Alonzo Chambliss CERTIFICATE OF MAILING Serial No. 10/815,813 I hereby certify that this correspondence is being deposited with the United States Postal Filed: April 2, 2004 Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, For: METHOD OF FABRICATING SEMICONDUCTOR DEVICE

Alexandria, VA 22313-1450, on February 2, 2007.

RESPONSE

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

UTILIZING LASER IRRADIATION

Dear Sir:

The Official Action mailed November 2, 2007, has been received and its contents carefully noted. This response is filed within three months of the mailing date of the Official Action and therefore is believed to be timely without extension of time. Accordingly, the Applicant respectfully submits that this response is being timely filed.

The Applicant notes with appreciation the consideration of the Information Disclosure Statements filed on April 2, 2004; January 13, 2006; and September 12, 2006. Applicant notes the partial consideration of the Information Disclosure Statement filed on August 17, 2006. The Applicant's representative conducted a telephone conference with Examiner Chambliss on December 8, 2006, during which agreement was reached that the foreign references cited at the bottom of page 1 of 2 from the Information Disclosure Statement filed August 17, 2006, including their attached translations, were fully considered by Examiner Chambliss. **Examiner Chambliss** explained that he placed an "X" through the dates and translation information out of a belief that such information is not of concern to the Publications Department. Also, agreement was reached that the Applicant would summarize this understanding in the